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APPLICANTS

Takeshi Kobayashi, Fukushima, JAPAN;

** CONTINUING DATA *****

This application is a 371 of PCT/JP04/11145 08/04/2004

** FOREIGN APPLICATIONS *****

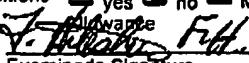
JAPAN 2003-292558 08/12/2003

JAPAN 2003-292539 08/12/2003

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met	STATE OR COUNTRY JAPAN	SHEETS DRAWING 7	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 1
Verified and Acknowledged Examiner's Signature 	Initials				

ADDRESS

25944

TITLE

Method for producing a wafer

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